

2015 International Workshop on EUV Lithography

Makena Beach & Golf Resort, Maui, Hawaii

June 15-19, 2015

Workshop Photographs ***June 15-19, 2015***



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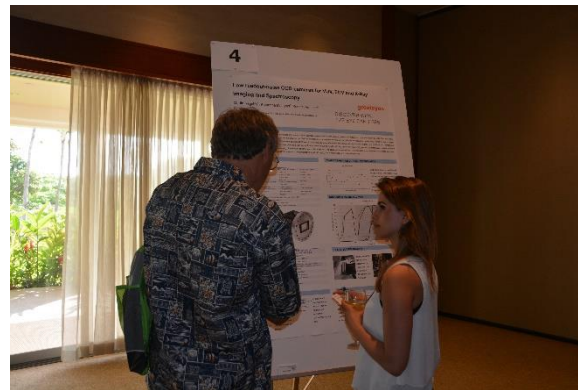
Photographs from 2015 EUVL Workshop

- Group Photo
- Workshop Presentations and Poster Session
- Reception
- Dinner
- Area Photographs

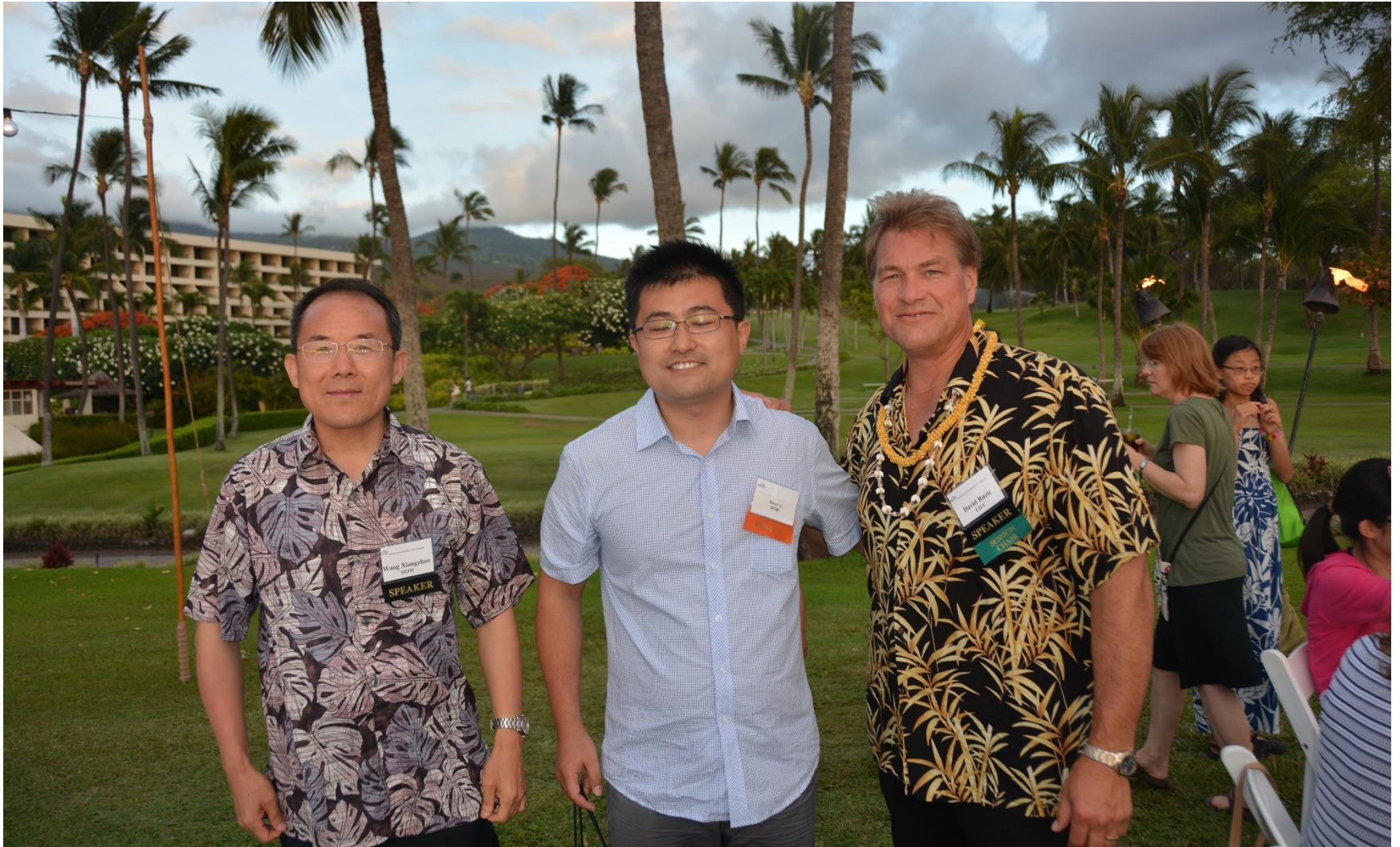
Group Photograph



Presentations and Poster Session



Poster Session Award



**Sikun Li and Xiangzhao Wang of Shanghai Institute for Optics and Fine Mechanics, China
(Award given by Prof. David Ruzic, UIUC, USA)**

Workshop Reception



Workshop Reception



Workshop Reception



Workshop Reception



Workshop Dinner



Workshop Dinner



Maui Area Photographs







